

C. Garion TE/VSC



The HiLumi LHC Design Study is included in the High Luminosity LHC project and is partly funded by the European Commission within the Framework Programme 7 Capacities Specific Programme, Grant Agreement 284404.



Outline:

- Vacuum system layout
 - Sectorization
 - Instrumentation
 - Supporting system
- Vacuum system components
 - General requirements
 - Vacuum chamber
 - Compensation system
 - C/W transition
- Assembly techniques
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Vacuum system layout

Sectorisation:

To avoid contamination, to ease the replacement of an element or the commissioning, a sector valve shall be installed on each line at both element extremities.

They are installed in case of warm vacuum sector/cold magnet(s) transition, collimators, cavities, ...

Typical closure time is 1 s.





Vacuum system layout

Instrumentation:

Interlock valve

Pirani/Penning

Each side of the value \rightarrow interlock for the value



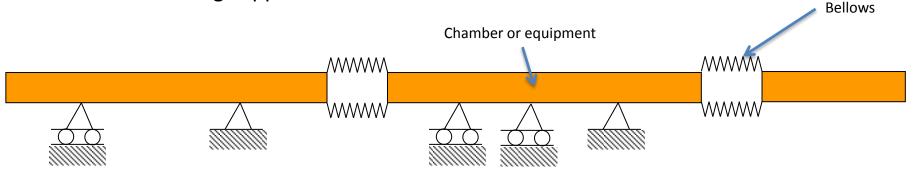


Vacuum system layout

Supporting system:

Principle:

- 1 fixed point per assembly between two bellows
- Other sliding supports



Under vacuum/atmospheric differential pressure, the fixed support has to withstand a longitudinal force induced by the difference of bellows cross-sections. Commissioning or maintenance scenario has to be taken into account (blank flange).

$$F_{\rightarrow Support} = P_{atm} \cdot \sum \overline{S}_{bellows}$$



Vacuum chambers:

Material:

- No polymer material (high outgassing rate, radiation damage) in the vacuum system.
- Temperature resistance: nominal 230 °C for NEG coated chambers, uncoated stainless steel: 250-300 °C.

Materials commonly used:

- ightarrow Stainless steel with low carbon and inclusion contents: 316L, 316LN
- \rightarrow Copper OFS
- \rightarrow Aluminium alloy: 2219

 \rightarrow Aluminium should be preferable used from radioprotection point of view. Assessment of other aluminium grades to be done for UHV applications: mechanical, vacuum and radioprotection aspects (collaboration with KEK, ActiWiz code).

Design:

For buckling resistance, the minimum thickness is around D/100 (stainless steel) to D/80 (aluminium)



Vacuum chambers:

Tolerances:

ISO-dimensions and tolerances for seamless tubes

- Standard high precision seamless tubes: D4 T3 (ISO 1127)
 - Class D4: OD: +/- 0.5 %
 - Class T3: Thickness: +/- 10 % (class T4: +/- 7.5%)

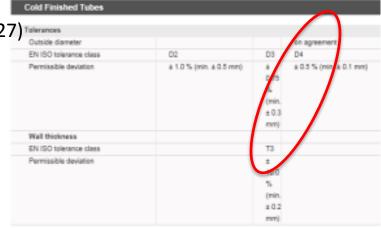
For info:

Luminosity

- Tube OD 147 +/- .74, t: 4 +/- 0.3
- → ID 139 +/- 1
 - Arc cold bore tube:
 - OD: 53 +/- 0.15
 - Thickness: 1.5 +/- 0.1
 - Straightness: 0.5 mm/m
- Machined long circular tube: (Input's from Manufacture de forage, tbc)
 - ID:1390/+0.1
 - Thickness: 4 +/- 0.5
 - Straightness: 0.3 mm/m

Straightness will be an important tolerance for the cold bore an the "stiff" beam screen.

Typical timeline for non-standard material procurement: ~ 1 year.



<u>Compensation system:</u> Bellows expansion joints

Material:

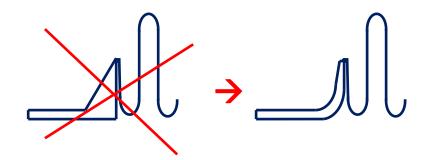
- convolutions: 316L, CERN specification 525
- End fittings in stainless steel: 316L or 316LN

Design:

- Hydroformed convolutions, baseline at cryogenic temperatures
- Bellows should conform to EJMA (formed bellows)
- Rule of thumb for low fatigue regime: convolution length = 2 * stroke

Manufacturing of the end fittings:

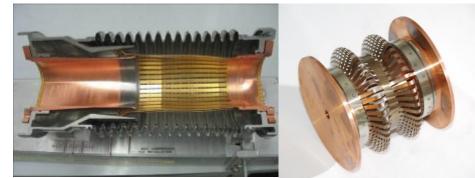
- no machining perpendicular to the fibers in "standard" material
- \rightarrow Flanged tube
- Machining from a 3D forged block





Compensation system:

RF fingers



Concept:

- Sliding fingers (baseline)
- Deformable fingers under study

PIM with sliding RF fingers

Deformable RF finger prototype

Material:

- Contact strips in gold plated (cryogenic temperature) or silver plated (room temperature) copper beryllium alloy
- OFE copper inserts coated by electroplated Rh

Interface:

- Preferably circular aperture,
- No geometrical transition (shape or offset) in the compensation system

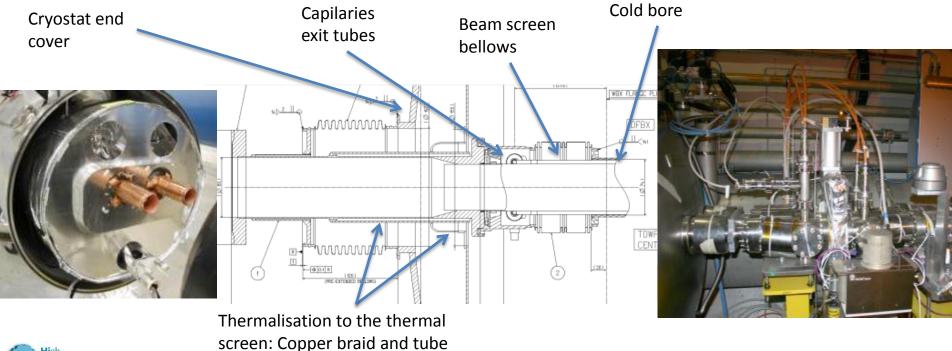




Cold/Warm transition:

Cold/warm transitions are installed between cold masses and warm vacuum sectors (sector valve).

Temperature profile has to be well controlled (thermal load, condensation on warm module).



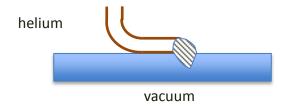


Assembly technics

Welds:

No weld between helium and vacuum

 \rightarrow Non penetrating weld onto the vacuum chamber



Welds on vacuum side or preferably 100% penetrating



Brazing:

Vacuum brazing shall be used for vacuum components.



Assembly techniques

Flanges:

ConFlat flanges is the baseline for stainless steel and copper vacuum chambers. Quick conical CF flanges have to be used in high radioactive areas.

Helicoflex are used in case of aluminium components. Alternative to helicoflex gasket has to be developed for aluminium flanges.

Screws:

Silver coated bolts (or screws if no bolts) have to be used for UHV assemblies in stainless steel.

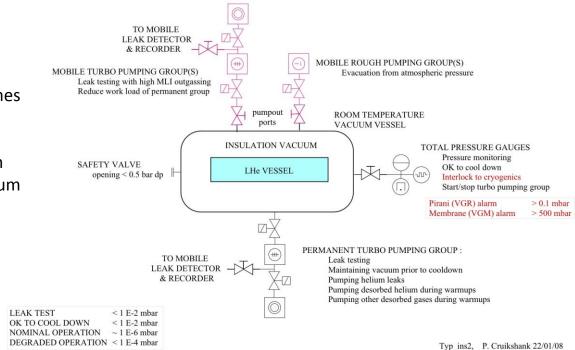
No trapped volume in vacuum (virtual leak): venting holes have to be done (either in the screw or at the bottom of the drilled hole).



Insulation vacuum

Concept:

- Sectorization of large vacuum volumes
- Decoupling cryogenic distribution line/magnet cryostat,
- Permanent turbo pumping group on each insulation vacuum sector (helium pumping),
- Additional pumping ports (leak detection, rough pumping),
- Pressure relief valve.



Potential issues for HL-LHC:

- Radiation resistance of electronics,
- Radiation resistance of elastomers



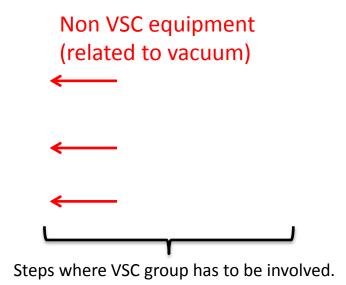


Quality assurance

Methodology:

Documentation sequence:

- 1. Conceptual specification
- 2. Functional specification
- 3. Engineering specification and technical drawings
- 4. Integration
- 5. ECR



All drawings of systems/components exposed to vacuum has to be checked and validated by TE/VSC.



Quality assurance

MTF:

VSC equipment will be recorded in MTF:

Top Assembly Id Other Identifier	dentifier: HCVC1A) : VA1	(002-CR	000001			
Description: VA	Aluminium Chamb	er Suba	ssembly			
		~				
Main Made of Equipment data	Manufacturing Operation C	ocuments 🔪 Hi	story Map			
external Links						
	No external data li	nk exists				
Property Values Property	Nominal Value		de of Equipment data			
Length Leak Check Accept no bak	e	Workflow	Diagram			
Leak Check Ac. after bake				workflow diagram is defined for this top as	sembly	
Degas Accept after bake					,	
Bake-out Temperature Ac.		Workflow	Steps			Last Repeat
NEG coating (Y/N)			R/E Other name	Description		Result N
Leak Check Ac. after NEG Bake-out Temperature NEG	c.	<u>10</u>	0	Reception Check	Pending	
Hydrogen pumping speed	6	<u>20</u>	0	Metrology I	Pending	
nyarogen paniping speed		<u>30</u>	0	Cleaning	Pending Pending	
123 (<i>F</i>	Z / 23	<u>40</u>	0	Vacuum Acceptance Test Metrology II (after bake-out)	Pending	
		<u>50</u> 60	0	Coating other than NEG	Pending	
		70	0	Wrapping for permanent bake-out jacket	Pending	
		80	0	NEG Coating	Pending	
		00		-	-	
		90	0	NEG Qualification Test	Pending	
		<u>90</u> 100	0	NEG Qualification Test Acceptance for storage	Pending Pending	

Vacuum acceptance tests are mandatory for VSC and non-VSC equipment.



Conclusion

Development of vacuum engineering for HL-LHC:

Design and integration of the beam screen (Roberto's talk):

- Properties of Inermet at cold
- Reliability of the interface Inermet/beam screen

Vacuum system in high radioactive environment:

- Aluminium alloy qualification for vacuum chambers and flanges
- Design compatible with remote tooling and/or handling
- Increase reliability of sensitive elements:
 - Sector valves
 - RF fingers

Insulation vacuum has not to be forgotten.







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